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| Form 1449* | Atty. Docket No.: 1327.011US1 | Serial No. Unknown |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) | Applicant: Harlan Theodore Jacobs et al. | |
| | Filing Date: Herewith | Group: Unknown |

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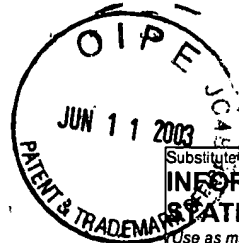
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| Application Number | 09/815884 |
| Filing Date | March 23, 2001 |
| First Named Inventor | Jacobs, Harlan |
| Group Art Unit | 1745 |
| Examiner Name | Unknown |

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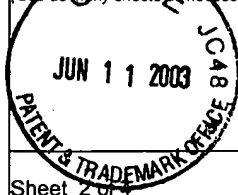
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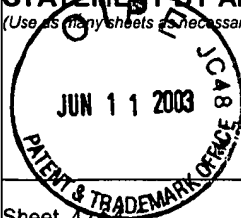
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